

OPTICAL RECORDING DISC AND METHOD FOR MANUFACTURING OPTICAL
RECORDING DISC

BACKGROUND OF THE INVENTION

Field of the Invention

5 The present invention relates to an optical recording disc and a method for manufacturing an optical disc and, particularly to an optical recording disc which can record data constituted by a recording mark train including recording marks and blank regions neighboring recording marks therein and reproduce the data therefrom in a desired manner even in the case where the
10 lengths of a recording mark and a blank region between neighboring recording marks are shorter than the resolution limit and whose storage capacity can be markedly increased and a method for manufacturing such an optical recording disc.

Description of the Related Art

15 Optical recording discs such as the CD, DVD and the like have been widely used as recording media for recording digital data and a optical recording disc that offers improved recording density and has an extremely high data transfer rate has been recently developed.

20 In such an optical recording disc, the storage capacity of the optical recording disc is improved by reducing a wavelength λ of a laser beam used for recording and reproducing data and increasing a numerical aperture NA of an objective lens, thereby reducing the diameter of the laser beam spot.

25 In an optical recording disc, in the case where the length of a recording mark formed in the optical recording disc and the length between neighboring recording marks, namely, the length of a region (hereinafter referred to

as "a blank region") where no recording mark is formed are shorter than the resolution limit, data cannot be reproduced from the optical recording disc.

The resolution limit is determined by the wavelength λ of a laser beam and the numerical aperture NA of an objective lens for converging the laser beam and in the case where the frequency of repetition of a recording mark and a blank region, namely, the spatial frequency, is equal to or larger than $2NA / \lambda$, data recorded in the recording mark and the blank region cannot be read.

Therefore, the length of the recording mark and the blank region corresponding to the spatial frequency which can be read both become equal to or
10 larger than $\lambda / 4NA$ and in the case where an objective lens having a numerical aperture NA is used to converge a laser beam having a wavelength λ on the surface of an optical recording disc, a recording mark having a length of $\lambda / 4NA$ and a blank region having a length of $\lambda / 4NA$ are the shortest recording mark and the shortest blank region which can be read.

15 Thus when data recorded in an optical recording disc are to be reproduced, there exists a resolution limit within which data can be read and the length of a recording mark and the length of a blank region which can be read are restricted. Therefore, if a recording mark having a length shorter than the resolution limit and a blank region having a length shorter than the resolution limit
20 are formed in an optical recording disc, thereby recording data therein, the thus recorded data cannot be reproduced, so that the length of a recording mark and the length of a blank region which can be formed for recording data in an optical recording disc are inevitably restricted and a recording mark having a length shorter than the resolution limit and a blank region having a length shorter than the
25 resolution limit are not normally formed in an optical recording disc to record data therein.

Therefore, in order to increase the storage capacity of an optical recording disc, it is required to shorten the wavelength λ of the laser beam used for reproducing data or increase the numerical aperture NA of the objective lens,

thereby decreasing the resolution limit so that data consisting of a recording mark having a shorter length and a blank region having a shorter length can be reproduced.

However, there is a limit to how far the wavelength λ of the laser

- 5 beam used for reproducing data can be shortened and how far the numerical aperture NA of the objective lens can be increased, so that the increase in the storage capacity of an optical recording disc that can be achieved by decreasing the resolution limit is limited.

Further, it is necessary for an optical recording disc to be constituted

- 10 so that in the case of increasing the storage capacity thereof by some means or other, a reproduced signal having a good signal characteristic can be obtained when data recorded in the optical recording disc are reproduced.

BRIEF SUMMARY OF THE INVENTION

It is therefore an object of the present invention to provide an optical

- 15 recording disc which can record data constituted by a recording mark train including recording marks and blank regions neighboring recording marks therein and reproduce the data therefrom in a desired manner even in the case where the lengths of a recording mark and a blank region between neighboring recording marks are shorter than the resolution limit and whose storage capacity can be
- 20 markedly increased and a method for manufacturing such an optical recording disc.

- The above object of the present invention can be accomplished by an optical recording disc constituted so that data can be recorded therein and reproduced therefrom by being irradiated with a laser beam, the optical recording
- 25 disc comprising a laminated body formed by laminating a decomposition reaction layer containing platinum oxide PtO_x as a primary component and a light absorbing layer so as to sandwich at least a dielectric layer, x in the chemical formula: PtO_x of the platinum oxide being equal to or larger than 1.0.

In a study done by the inventors of the present invention, it was found that in the case where the optical disc including a decomposition reaction layer containing platinum oxide PtO_x as a primary component was irradiated with a laser beam, thereby forming a recording mark in the decomposition reaction layer 5 and recording data in the optical recording disc, even if the lengths of a recording mark and a blank region between neighboring recording marks which constituted a recording mark train were shorter than the resolution limit, data could be reproduced from the optical recording disc.

Thus, since it is possible to reproduce data even in the case where 10 the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit, it is possible to record data in the optical recording disc at a high density and it is therefore possible to markedly increase the storage capacity of the optical recording disc.

15 Further, in the present invention, the decomposition reaction layer is formed so that x in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.0 and in a study done by the inventors of the present invention, it was found that in the case where the decomposition reaction layer was formed by adjusting the content of oxygen so that x in the chemical formula: PtO_x of the 20 platinum oxide was equal to or larger than 1.0, it was possible to suppress the level of a noise signal contained in a signal obtained by reproducing data recorded in the optical recording disc and simultaneously suppress the variation of the amplitude of the reproduced signal.

Although it is not altogether clear why forming the decomposition 25 reaction layer so that x in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.0 makes it possible to suppress the level of a noise signal contained in a signal obtained by reproducing data recorded in the optical recording disc and simultaneously suppress the variation of the amplitude of the reproduced signal, it is reasonable to conclude that setting x in the chemical

formula: PtO_x of the platinum oxide to be equal to or larger than 1.0 enables the light absorption coefficient *k* of the decomposition reaction layer to be lowered and the transparency of the decomposition reaction layer with respect to a laser beam to be increased, whereby the transparency of the blank region where the platinum oxide PtO_x remains unchanged with respect to the laser beam is increased and undesirable reflected light causing a noise signal is prevented from being generated in the blank region when data are reproduced from the optical recording disc.

Therefore, according to the present invention, even in the case
10 where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit, it is possible to obtain a reproduced signal having a good signal characteristic.

In a preferred aspect of the present invention, the decomposition
15 reaction layer is formed so that *x* in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.5.

In a preferred aspect of the present invention, a bubble pit is formed in the decomposition reaction layer and fine particles of platinum are precipitated into the bubble pit when the decomposition reaction layer is irradiated with the
20 laser beam, thereby forming a recording mark in the decomposition reaction layer.

In a study done by the inventors of the present invention, it was found that in the case where a bubble pit was formed in the decomposition reaction layer and fine particles of platinum were precipitated into the bubble pit when the decomposition reaction layer was irradiated with the laser beam, thereby
25 forming a recording mark in the decomposition reaction layer, even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train was shorter than the resolution limit, data could be reproduced.

Thus it was observed that in the case where a bubble pit is formed in the decomposition reaction layer and fine particles of platinum precipitate into the bubble pit, thereby forming a recording mark in the decomposition reaction layer and recording data in the optical recording disc, it is possible to reproduce the data

- 5 recorded in the optical recording disc even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit.

Although the reason for this is not altogether clear, it is reasonable to conclude that near-field light is generated by irradiating the fine particles of platinum with the

- 10 laser beam for reproducing data and the resolution limit disappears or that the resolution limit becomes smaller due to the interaction between the fine particles of platinum precipitated into the bubble pit and the laser beam with which the fine particles of platinum are irradiated.

Therefore, according to the present invention, the storage capacity of
15 an optical recording disc can be markedly increased.

In the present invention, it is preferable for the platinum oxide contained in the decomposition reaction layer as a primary component to be decomposed into platinum and oxygen.

In the present invention, the light absorption layer preferably contains
20 a material having a high absorption coefficient with respect to a laser beam and low thermal conductivity and more preferably contains at least one of Sb and Te.

In the present invention, as an alloy contained in the light absorption layer and containing at least one of Sb and Te, an alloy represented by the general formula: $(Sb_aTe_{1-a})_{1-b}M_b$ or $\{(GeTe)_c(Sb_2Te_3)_{1-c}\}_dX_{1-d}$ is particularly preferable.

- 25 Here, the element M represents an element other than Sb and Te and the element X represents an element other than Sb, Te and Ge.

In the case where the alloy which contains at least one of Sb and Te and is contained in the light absorption layer is represented by the general formula: $(Sb_aTe_{1-a})_{1-b}M$, it is preferable for a and b to be such that a is equal to or larger

than 0 and equal to or smaller than 1 and that **b** is equal to or larger than 0 and equal to or smaller than 0.25. In the case where **b** is larger than 0.25, the light absorption coefficient of the light absorption layer becomes lower than the required value and the thermal conductivity thereof becomes lower than the required value.

5 The element M is not particularly limited but it is preferable for the element M to be at least one element selected from a group consisting of In, Ag, Au, Bi, Se, Al, Ge, P, H, Si, C, V, W, Ta, Zn, Mn, Ti, Sn, Pb, Pd, N, O and rare earth elements (Sc, Y and lanthanoid) as a primary component.

On the other hand, in the case where the alloy which contains at
10 least one of Sb and Te and is contained in the light absorption layer is represented by the general formula: $\{(GeTe)_c(Sb_2Te_3)_{1-c}\}_dX_{1-d}$, it is preferable for **c** and **d** to be such that **c** is equal to or larger than 1/3 and equal to or smaller than 2/3 and **d** is equal to or larger than 0.9.

The element X is not particularly limited but it is preferable for the
15 element M to be at least one element selected from a group consisting of In, Ag, Au, Bi, Se, Al, P, H, Si, C, V, W, Ta, Zn, Mn, Ti, Sn, Pb, Pd, N, O and rare earth elements as a primary component.

In the present invention, it is preferable for the dielectric layer and the light absorption layer to be deformed when the optical recording disc is irradiated
20 with the laser beam, whereby the decomposition reaction layer is decomposed into noble metal and oxygen and the bubble pit is formed.

Since deformed regions of the dielectric layer and the light absorption layer have different optical characteristics from regions where they are not deformed, it is possible to further improve the C/N ratio of the reproduced signal.

25 The above objects of the present invention can be also accomplished by an optical recording disc constituted so that data can be recorded therein and reproduced therefrom by being irradiated with a laser beam, the optical recording disc comprising a laminated body formed by laminating a decomposition reaction layer containing platinum oxide PtOx as a primary component and a light

absorbing layer so as to sandwich at least a dielectric layer, the decomposition reaction layer having a light absorption coefficient k equal to or lower than 2.0.

In a preferred aspect of the present invention, the decomposition reaction layer has a light absorption coefficient k equal to or lower than 1.0.

- 5 The above objects of the present invention can be also accomplished by a method for manufacturing an optical recording disc comprising a laminated body formed by laminating a decomposition reaction layer containing platinum oxide PtO_x as a primary component and a light absorbing layer so as to sandwich at least a dielectric layer and constituted so that data can be recorded therein and
- 10 reproduced therefrom by being irradiated with a laser beam, the method for manufacturing an optical recording disc comprising steps of applying power onto a target containing platinum as a primary component with a power density smaller than 4 W/cm² in a sputtering gas atmosphere containing oxygen in an amount of a flow ratio equal to or larger than 10 % and forming the decomposition reaction
- 15 layer by a sputtering process.

In the case of forming a decomposition reaction layer under these film forming conditions, it is possible to form the decomposition reaction layer containing platinum oxide PtO_x as a primary component where x in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.0 and having a light absorption coefficient k equal to or lower than 1.0. Therefore, according to the present invention, it is possible to manufacture an optical recording disc from which a reproduced signal having a good signal characteristic can be obtained even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is

20 shorter than the resolution limit.

In a preferred aspect of the present invention, the decomposition reaction layer is formed by setting the power density to be smaller than 2 W/cm².

In a further preferred aspect of the present invention, the decomposition reaction layer is formed by setting a pressure in a chamber to be

equal to or higher than 0.5 Pa when the sputtering gas is introduced into the chamber.

In a further preferred aspect of the present invention, the decomposition reaction layer is formed by setting a film forming rate for forming the 5 decomposition reaction layer to be lower than 250 Å/min.

According to the present invention, it is possible to provide an optical recording disc which can record data constituted by a recording a mark train including recording marks and blank regions neighboring recording marks therein and reproduce the data therefrom in a desired manner even in the case where the 10 lengths of a recording mark and a blank region between neighboring recording marks are shorter than the resolution limit and whose storage capacity can be markedly increased and a method for manufacturing such an optical recording disc.

BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWINGS

15 Figure 1 is a schematic cross sectional view showing an optical recording disc that is a preferred embodiment of the present invention.

Figure 2 is an enlarged schematic cross-sectional view of the part of the optical recording disc in Figure 1 indicated by A.

20 Figure 3 (a) is a partly enlarged schematic cross-sectional view of an optical recording disc before data are recorded therein and Figure 3 (b) is a partly enlarged schematic cross-sectional view of an optical recording disc after data were recorded therein.

Figure 4 is a schematic perspective view showing an optical recording disc that is another preferred embodiment of the present invention.

25 Figure 5 is an enlarged schematic cross-sectional view of the part of the optical recording disc in Figure 4 indicated by B.

Figure 6 is a diagram showing the frequency spectrum of a reproduced signal obtained from an optical recording disc sample # 1 displayed on the screen of a spectrum analyzer.

5 Figure 7 is a diagram showing the frequency spectrum of a reproduced signal obtained from an optical recording disc sample # 2 displayed on the screen of a spectrum analyzer.

Figure 8 is a diagram showing the frequency spectrum of a reproduced signal obtained from an optical recording disc sample # 3 displayed on the screen of a spectrum analyzer.

10 Figure 9 is a diagram showing the frequency spectrum of a reproduced signal obtained from an optical recording disc sample # 4 displayed on the screen of a spectrum analyzer.

Figure 10 is a diagram showing the waveform of a reproduced signal of an optical recording disc sample # 1 displayed on the screen of an oscilloscope.

15 Figure 11 is a diagram showing the waveform of a reproduced signal of an optical recording disc sample # 2 displayed on the screen of an oscilloscope.

Figure 12 is a diagram showing the waveform of a reproduced signal of an optical recording disc sample # 3 displayed on the screen of an oscilloscope.

DETAILED DESCRIPTION OF THE INVENTION

20 Hereinafter, preferred embodiments of the present invention will be described in detail with reference to accompanying drawings.

Figure 1 is a schematic cross sectional view showing an optical recording disc that is a preferred embodiment of the present invention and Figure 2 is an enlarged schematic cross-sectional view of the part of the optical recording 25 disc in Figure 1 indicated by A.

As shown in Figure 2, an optical recording disc 1 according to this embodiment includes a light transmissible substrate 2, and a first dielectric layer 4, a decomposition reaction layer 5, a second dielectric layer 6, a light absorption

layer 7 and a third dielectric layer 8 laminated on the light transmissible substrate 2 in this order.

As shown in Figure 2, in this embodiment, the optical recording disc 1 is constituted so that data are recorded therein and recorded data are
5 reproduced therefrom by irradiating the optical recording disc 1 with a laser beam L from the side of the light transmissible substrate 2. The laser beam L has a wavelength of 635 nm to 660 nm and is converged onto the optical recording disc 1 using an objective lens having a numerical aperture of 0.59 to 0.66.

The light transmissible substrate 2 is a layer through which the laser
10 beam L is transmitted when data are to be recorded in the decomposition reaction layer 5 and data recorded in the decomposition reaction layer 5 are to be reproduced. It serves as a support of the optical recording disc 1 for ensuring mechanical strength required for the optical recording disc 1.

The light transmissible substrate 2 is formed disc-like so as to have a
15 thickness of about 0.6 mm that depends upon the design of an optical system used for recording and reproducing data.

One of the major surfaces of the light transmissible substrate 2 constitutes a light incidence plane through which the laser beam L enters, and grooves (not shown) and lands (not shown) are spirally formed on the other major
20 surface of the light transmissible substrate 2 so as to extend from a portion in the vicinity of the center of the light transmissible substrate 2 toward the outer circumference.

The grooves and/or lands serve as a guide track for the laser beam L when data are to be recorded in the decomposition reaction layer 5 and data
25 recorded in the decomposition reaction layer 5 are to be reproduced.

The material usable for forming the light transmissible substrate 2 is not particularly limited insofar as it has optical transparency with respect to a laser beam having a wavelength of 635 nm to 660 nm and can serve as a support of the optical recording disc 1. The light transmissible substrate 2 can be formed of

glass, ceramic, resin or the like. Illustrative examples of resins suitable for forming the light transmissible substrate 2 include polycarbonate resin, polyolefin resin, acrylic resin, epoxy resin, polystyrene resin, polyethylene resin, polypropylene resin, silicone resin, fluoropolymers, acrylonitrile butadiene styrene resin, urethane resin and the like. Among these, polycarbonate resin and polyolefin resin are most preferably used for forming the light transmissible substrate 2 from the viewpoint of easy processing, optical characteristics and the like.

As shown in Figure 2, the first dielectric layer 4 is formed on the surface of the light transmissible substrate 2 of the optical recording disc 1.

In this embodiment, the first dielectric layer 4 serves to physically and chemically protect the decomposition reaction layer 5 as described later and the light transmissible substrate 2.

The dielectric material usable for forming the first dielectric layer 4 is not particularly limited and the first dielectric layer 4 can be formed of a dielectric material containing oxide, sulfide, nitride or the combination thereof as a primary component. It is preferable to form the first dielectric layer 4 of oxide, nitride, sulfide or fluoride containing at least one element selected from a group consisting of Si, Zn, Al, Ta, Ti, Co, Zr, Pb, Ag, Sn, Ca, Ce, V, Cu, Fe and Mg, or a combination thereof.

The thickness of the first dielectric layer 4 is not particularly limited but it is preferable to form the first dielectric layer 4 so as to have a thickness of 5 nm to 300 nm.

As shown in Figure 2, the decomposition reaction layer 5 is formed on the surface of the first dielectric layer 4 of the optical recording disc 1.

In this embodiment, the decomposition reaction layer 5 serves as a recording layer and a recording mark is formed in the decomposition reaction layer 5 when data are to be recorded in the optical recording disc 1.

In this embodiment, the decomposition reaction layer 5 contains platinum oxide (PtO_x) as a primary component.

In this embodiment, in order to obtain a reproduced signal having a good signal characteristic even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks is shorter than the resolution limit, the decomposition reaction layer 5 is formed by adjusting the 5 content of oxygen so that x in the chemical formula: PtO x of the platinum oxide is equal to or larger than 1.0 and the decomposition reaction layer 5 has a light absorption coefficient k equal to or lower than 2.0 with respect to a laser beam L having a wavelength λ of 635 nm to 660 nm.

In this embodiment, in order to obtain a reproduced signal having a 10 better signal characteristic, it is preferable for x in the chemical formula: PtO x of the platinum oxide to be equal to or larger than 1.5 and it is preferable for the light absorption coefficient k to be equal to or lower than 1.0.

The decomposition reaction layer 5 is formed so as to have a thickness of 2 nm to 20 nm and is preferably formed so as to have a thickness of 4 15 nm to 20 nm. However, the thickness of the decomposition reaction layer 6 is not particularly limited insofar as it falls within this range.

It is thought that in the case where the thickness of the decomposition reaction layer 5 is too thin, the decomposition reaction layer 5 sometimes cannot be formed as a continuous film, and on the other hand, that in 20 the case where the thickness of the decomposition reaction layer 5 is too thick, the decomposition reaction layer 5 does not readily deform and it becomes difficult to form a bubble pit having a desired shape as the length of a recording mark to be formed becomes shorter. Thus, it is preferable to form the decomposition reaction layer 5 so as to have a thickness of 2 nm to 20 nm and it is more preferable to 25 form it so as to have a thickness of 4 nm to 20 nm.

As shown in Figure 2, the second dielectric layer 6 is formed on the surface of the decomposition reaction layer 5 of the optical recording disc 1.

In this embodiment, the second dielectric layer 6 serves to physically and chemically protect the decomposition reaction layer 5 and the light absorption layer 7 as described later.

The material usable for forming the second dielectric layer 6 is not particularly limited and the second dielectric layer 6 can be formed of the same material as that for forming the first dielectric layer 4, for example.

It is preferable to form the second dielectric layer 6 so as to have a thickness of 5 nm to 100 nm.

As shown in Figure 2, the light absorption layer 7 is formed on the surface of the second dielectric layer 6 of the optical recording disc 1.

In this embodiment, the light absorption layer 7 serves to absorb a laser beam L whose power is set to the recording power and which is irradiated onto the optical recording disc 1, generate heat and transfer the thus generated heat to the decomposition reaction layer 5.

In this embodiment, the light absorption layer 7 is formed of an alloy containing one of Sb and Te having a high light absorption coefficient and low thermal conductivity.

As an alloy contained in the light absorption layer 7 and containing one of Sb and Te, an alloy represented by the general formula: $(Sb_aTe_{1-a})_{1-b}M_b$ or $\{(GeTe)_c(Sb_2Te_3)_{1-c}\}_dX_{1-d}$ is particularly preferable. Here, the element M represents an element other than Sb and Te and the element X represents an element other than Sb, Te and Ge.

In the case where the alloy which contains at least one of Sb and Te and is contained in the light absorption layer 7 is represented by the general formula: $(Sb_aTe_{1-a})_{1-b}M$, it is preferable for a and b to be such that a is equal to or larger than 0 and equal to or smaller than 1 and that b is equal to or larger than 0 and equal to or smaller than 0.25. In the case where b is larger than 0.25, the light absorption coefficient of the light absorption layer 7 becomes lower than the

required value and the thermal conductivity thereof becomes lower than the required value required.

The element M is not particularly limited but it is preferable for the element M to be at least one element selected from a group consisting of In, Ag,

- 5 Au, Bi, Se, Al, Ge, P, H, Si, C, V, W, Ta, Zn, Mn, Ti, Sn, Pb, Pd, N, O and rare earth elements (Sc, Y and lanthanoid) as a primary component.

On the other hand, in the case where the alloy contained in the light absorption layer 7 and containing at least one of Sb and Te is represented by the general formula: $\{(GeTe)_c(Sb_2Te_3)_{1-c}\}_dX_{1-d}$, it is preferable for **c** and **d** to be such

- 10 that **c** is equal to or larger than 1/3 and equal to or smaller than 2/3 and **d** is equal to or larger than 0.9.

The element X is not particularly limited but it is preferable for the element M to be at least one element selected from a group consisting of In, Ag, Au, Bi, Se, Al, P, H, Si, C, V, W, Ta, Zn, Mn, Ti, Sn, Pb, Pd, N, O and rare earth

- 15 elements as a primary component.

It is preferable for the light absorption layer 7 to have a thickness of 5 nm to 100 nm. In the case where the thickness of the light absorption layer 7 is smaller than 5 nm, the amount of light absorbed therein becomes too small and on the other hand, in the case where the thickness of the light absorption layer 7 is 20 larger than 100 nm, the light absorption layer 7 does not readily deform when a bubble pit is formed in the decomposition reaction layer 5 as described later.

As shown in Figure 2, the third dielectric layer 8 is formed on the surface of the light absorption layer 7 of the optical recording disc 1.

- In this embodiment, the third dielectric layer 8 serves to physically 25 and chemically protect the light absorption layer 7 in cooperation with the second dielectric layer 6.

The material usable for forming the third dielectric layer 8 is not particularly limited and the third dielectric layer 8 can be formed of the same material as that for forming the first dielectric layer 4, for example.

The thickness of the third dielectric layer 8 is not particularly limited but it is preferable to form the third dielectric layer 8 so as to have a thickness of 5 nm to 300 nm.

The optical recording disc 1 having the above-described
5 configuration can, for example, be fabricated in the following manner.

The light transmissible substrate 2 having the grooves and the lands on the surface thereof is first fabricated by an injection molding process.

The first dielectric layer 4 is then formed on the surface of the light transmissible substrate 2 on which the grooves and the lands are formed. The first
10 dielectric layer 4 can be formed on the surface of the light transmissible substrate 2 by a gas phase growth process using chemical species containing elements for forming the first dielectric layer 4. Illustrative examples of the gas phase growth processes include a vacuum deposition process, a sputtering process and the like.

15 Further, the decomposition reaction layer 5 is formed on the surface of the first dielectric layer 4. The decomposition reaction layer 5 can be formed on the surface of the first dielectric layer 4 by a gas phase growth process using chemical species containing elements for forming the decomposition reaction layer 5.

20 In this embodiment, a reactive sputtering process is employed as the gas phase growth process and a target containing platinum as a primary component is sputtered in a mixed gas atmosphere of an Ar gas and an oxygen gas, whereby the decomposition reaction layer 5 containing platinum oxide as a primary component is formed.

25 In the case where the decomposition reaction layer 5 is formed by the reactive sputtering process, a ratio of the Ar gas and the oxygen gas contained in the mixed gas, a power density which is a power applied to the target per unit area of the target and a gas pressure which is a pressure within a chamber when introducing an Ar gas and an oxygen gas into a chamber to prepare a mixed gas of

the Ar gas and the oxygen gas are basic conditions for forming the decomposition reaction layer 5.

In this embodiment, the decomposition reaction layer 5 is formed in accordance with a sputtering process by setting a flow ratio of oxygen in the mixed

- 5 gas of the Ar gas and the oxygen gas to be equal to or larger than 10 % and setting the power density to be smaller than 4 W/cm^2 and it is preferable to form the decomposition reaction layer 5 in accordance with a sputtering process by further setting the gas pressure to be equal to or higher than 0.5 Pa.

Then, the second dielectric layer 6 is formed on the surface of the
10 decomposition reaction layer 5. The second dielectric layer 6 can be formed on the surface of the decomposition reaction layer 5 by a gas phase growth process using chemical species containing elements for forming the second dielectric layer 6. Illustrative examples of the gas phase growth processes include a vacuum deposition process, a sputtering process and the like.

15 Further, the light absorption layer 7 is formed on the surface of the second dielectric layer 6. The light absorption layer 7 can be formed on the surface of the second dielectric layer 6 by a gas phase growth process using chemical species containing elements for forming the light absorption layer 7.

Similarly to the case of forming the first dielectric layer 4, illustrative examples of
20 the gas phase growth processes include a vacuum deposition process, a sputtering process and the like.

Then, the third dielectric layer 8 is formed on the surface of light absorption layer 7. The third dielectric layer 8 can be formed on the surface of light absorption layer 7 by a gas phase growth process using chemical species
25 containing elements for forming the third dielectric layer 8. Similarly to the case of forming the first dielectric layer 4, illustrative examples of the gas phase growth processes include a vacuum deposition process, a sputtering process and the like.

Thus, the optical recording disc 1 is manufactured.

Data are recorded in and reproduced from the thus constituted optical recording disc 1 as set out in the following.

- Figure 3 (a) is a partly enlarged schematic cross-sectional view of the optical recording disc 1 before data were recorded therein and Figure 3 (b) is a
- 5 partly enlarged schematic cross-sectional view of the optical recording disc 1 after data were recorded therein.

When data are to be recorded in the optical recording disc 1, the optical recording disc 1 is irradiated with a laser beam L from the side of the light transmissible substrate 2.

- 10 In this embodiment, the laser beam L having a wavelength λ of 635 nm to 660 nm is converged onto the optical recording disc 1 using an objective lens having a numerical aperture NA of 0.59 to 0.66.

- The power of the laser beam L is determined so as to be higher than 4 mW and equal to or lower than 30 mW. Here, the power of the laser beam L is
- 15 defined as the power of the laser beam L on the surface of the optical recording disc 1.

- When the optical recording disc 1 is irradiated from the side of the light transmissible substrate 2 with the laser beam L whose power is set to the recording power, since the light absorption layer 7 is formed of an alloy containing
- 20 one of Sb and Te having a high light absorption coefficient, the region of the light absorption layer 7 irradiated with the laser beam L is heated.

- Heat generated in the light absorption layer 7 is transferred to the decomposition reaction layer 5 and the temperature of the decomposition reaction layer 6 increases. Thus, the decomposition reaction layer 5 is heated to a
- 25 temperature equal to or higher than the decomposition temperature of the platinum oxide contained in the decomposition reaction layer 5 as a primary component is decomposed into platinum and oxygen.

As a result, as shown in Figure 3 (b), a bubble pit 5a is formed in the decomposition reaction layer 5 by an oxygen gas generated by the decomposition

of the platinum oxide and fine particles 5b of platinum precipitate into the bubble pit 5a.

As shown in Figure 3 (b), in this embodiment, at the same time, the second dielectric layer 6 and the light absorption layer 7 are deformed together
5 with the decomposition reaction layer 5 by the pressure of the oxygen gas.

Since the region where the bubble pit 5a is formed and the decomposition reaction layer 5, the second dielectric layer 6 and the light absorption layer 7 are deformed in this manner has different optical properties from those of other regions, a recording mark is constituted by the region where the
10 bubble pit 6a is formed and the decomposition reaction layer 5, the second dielectric layer 6 and the light absorption layer 7 are deformed.

In this embodiment, thus formed recording marks and blank regions between neighboring recording marks include ones having a length shorter than $\lambda / 4NA$ and a recording mark train including recording marks and blank regions
15 having lengths shorter than the resolution limit is formed.

Further, in this embodiment, the decomposition reaction layer 5 contains platinum oxide having a high decomposition temperature as a primary component, so that when the optical recording disc 1 is irradiated with a laser beam L whose power is set to the recording power to form a recording mark, it is
20 possible to prevent the decomposition reaction of platinum oxide from occurring in regions other than the region irradiated with the laser beam L even if heat is diffused from the region of the decomposition reaction layer 5 irradiated with the laser beam L to regions of the decomposition reaction layer 5 therearound. Therefore, it is possible to form the bubble pit 5a at a desired region of the
25 decomposition reaction layer 5 to form a recording mark therein.

Thus, data are recorded in the optical recording disc 1. Data recorded in the optical recording disc 1 are reproduced in the following manner.

When data recorded in the optical recording disc 1 are to be reproduced, the laser beam L having a wavelength λ of 635 nm to 660 nm is first

converged onto the optical recording disc 1 using an objective lens having a numerical aperture NA of 0.59 to 0.66.

In this embodiment, the power of the laser beam L used for reproducing data from the optical recording disc 1 is set higher than usual and
5 normally set to 1 mW to 5 mW.

In a study done by the inventors of the present invention, it was found that in the case where the optical recording disc 1 is irradiated with the laser beam L having a wavelength λ of 635 nm to 660 nm using an objective lens having a numerical aperture NA of 0.59 to 0.66 from the side of the light transmissible
10 substrate 2, data can be reproduced even when the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit.

Although it is not altogether clear why, in the case where the platinum oxide contained in the decomposition reaction layer 5 as a primary
15 component is decomposed into platinum and oxygen, a bubble pit 5a is formed in the decomposition reaction layer 5 and fine particles 5b of platinum precipitate into the bubble pit 5a by the thus generated oxygen gas, thereby forming a recording mark in the decomposition reaction layer 5 and recording data in the optical recording disc 1, whereby it is possible to reproduce data recorded in the optical
20 recording disc 1 even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit, it is reasonable to conclude that near-field light is generated by irradiating the fine particles 5b of platinum precipitated into the bubble pit 5a with the laser beam L and the resolution limit
25 disappears or that the resolution limit becomes smaller due to the interaction between the fine particles 5b of platinum precipitated into the bubble pit 5a and the laser beam L with which the fine particles 5b of platinum are irradiated.

In this embodiment, since the decomposition reaction layer 5 contains the platinum oxide whose decomposition temperature is high as a primary

component, even when data are to be reproduced by irradiating the optical recording disc 1 with the laser beam L for reproducing data having a high power, there is no risk of platinum oxide decomposing into platinum and oxygen.

Therefore, even in the case of repeatedly reproducing data recorded in the optical recording disc 1, a bubble pit 5a can be formed without change in the shape of a recording mark and a new bubble pit is not formed at regions other than the region where the recording mark is formed. Accordingly, it is possible to improve the reproduction durability of the optical recording disc 1.

Further, in this embodiment, the decomposition reaction layer is formed so that x in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.0 and the decomposition reaction layer has a light absorption coefficient k equal to or lower than 2.0 and in a study done by the inventors of the present invention, it was found that in the case where the decomposition reaction layer was formed so that x in the chemical formula: PtO_x of the platinum oxide was equal to or larger than 1.0 and the decomposition reaction layer had a light absorption coefficient k equal to or lower than 2.0, it was possible to suppress the level of a noise signal contained in a signal obtained by reproducing data recorded in the optical recording disc and simultaneously suppress variation of the amplitude of the reproduced signal.

Although it is not altogether clear why forming the decomposition reaction layer so that x in the chemical formula: PtO_x of the platinum oxide is equal to or larger than 1.0 and the decomposition reaction layer has a light absorption coefficient k equal to or lower than 2.0 makes it possible to suppress the level of a noise signal contained in a signal obtained by reproducing data recorded in the optical recording disc and simultaneously suppress the variation of the amplitude of the reproduced signal, it is reasonable to conclude that in the case where the decomposition reaction layer 5 having such a composition and an optical characteristic is formed, the transparency of the decomposition reaction layer 5 with respect to the laser beam L can be increased, whereby the transparency of

the blank region where the platinum oxide PtO_x remains unchanged with respect to the laser beam is increased and undesirable reflected light causing a noise signal is prevented from being generated in the blank region when the decomposition reaction layer 5 is irradiated with the laser beam L and data are reproduced from the optical recording disc 1.

Therefore, according to this preferred embodiment, even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit, it is possible to obtain a reproduced signal having a good signal characteristic.

Figure 4 is a schematic perspective view showing an optical recording disc which is another preferred embodiment of the present invention and Figure 5 is an enlarged schematic cross-sectional view of the part of the optical recording disc in Figure 4 indicated by B within a cross section taken along the track of the optical recording disc.

As shown in Figure 5, an optical recording disc 10 according to this embodiment includes a support substrate 12, and a third dielectric layer 8, a light absorption layer 7, a second dielectric layer 6, a decomposition reaction layer 5, a first dielectric layer 4 and a light transmission layer 13 are laminated on the support substrate 12 in this order.

As shown in Figure 5, in this embodiment, the optical recording disc 10 is constituted so that data are recorded and data recorded therein are reproduced by being irradiated with a laser beam L from the side of the light transmission layer 9. The laser beam L has a wavelength of 390 nm to 420 nm and is converged onto the optical recording disc 1 using an objective lens having a numerical aperture of 0.70 to 0.90.

The support substrate 12 serves as a support of the optical recording disc 10 for ensuring mechanical strength required for the optical recording disc 10.

The material used to form the support substrate 12 is not particularly limited insofar as the support substrate 12 can serve as the support of the optical recording disc 10. Similarly to the light transmissible substrate 2 shown in Figure 2, the support substrate 12 can be formed of glass, ceramic, resin or the like.

5 In this embodiment, the support substrate 12 is formed of polycarbonate resin and has a thickness of about 1.1 mm.

The light transmission layer 13 is a layer through which the laser beam L is transmitted and the surface thereof forms a light incidence plane of the laser beam L.

10 The material for forming the light transmission layer 13 is not particularly limited insofar as it is optically transparent and has a low absorption ratio and a reflectivity with respect to a laser beam having a wavelength of 390 nm to 420 nm of the wavelength of the laser beam L, and a low birefringence factor. In the case where the light transmission layer 13 is formed using a spin coating
15 method or the like, an ultraviolet ray curable resin, an electron beam curable resin, a thermosetting resin or the like can be used for forming the light transmission layer 13 and an activated energy ray curable type resin such as an ultraviolet ray curable resin and an electron beam curable resin is most preferably used for forming the light transmission layer 13.

20 The light transmission layer 13 may be formed by adhering a sheet formed of light transmittable resin onto the surface of the first dielectric layer 4 using an adhesive agent.

In the case where the light transmission layer 13 is formed using a spin coating method, the thickness thereof is preferably 10 µm to 200 µm and in
25 the case where the light transmission layer 13 is formed by adhering a sheet formed of light transmittable resin onto the surface of the first dielectric layer 4 using an adhesive agent, the thickness thereof is preferably 50 µm to 150 µm.

Data are recorded in and reproduced from the thus constituted optical recording disc 10 as set out in the following.

When data are to be recorded in the optical recording disc 10, the optical recording disc 1 is irradiated with a laser beam L from the side of the light transmission layer 13.

In this embodiment, the laser beam L having a wavelength λ of 390 nm to 420 nm is converged onto the optical recording disc 1 using an objective lens having a numerical aperture NA of 0.7 to 0.9.

When the optical recording disc 1 is irradiated with the laser beam L whose power is set to the recording power, the decomposition reaction layer 5 is heated to a temperature equal to or higher than the decomposition temperature of platinum oxide and the platinum oxide contained in the decomposition reaction layer 5 as a primary component is decomposed into platinum and oxygen.

As a result, similarly to in the optical recording disc 10 and as shown in Figure 3, a bubble pit 5a is formed in the decomposition reaction layer 5 by an oxygen gas generated by the decomposition of the platinum oxide and fine particles 5b of platinum precipitate into the bubble pit 5a. At the same time, the second dielectric layer 6 and the light absorption layer 7 are deformed together with the decomposition reaction layer 5 by the pressure of the oxygen gas.

Data thus recorded in the optical recording disc 10 are reproduced by converging the laser beam having a wavelength λ of 390 nm to 420 nm onto the optical recording disc 10 using the objective lens having a numerical aperture NA of 0.7 to 0.9 and detecting the laser beam reflected from the optical recording disc 10.

As described above, according to this preferred embodiment, if a recording mark is formed in the decomposition reaction layer 5 by forming the bubble pit in the decomposition reaction layer 5 and precipitating platinum fine particles into the bubble pit, data can be reproduced even when the lengths of a recording mark and a blank region between neighboring recording marks which constitute a recording mark train are shorter than the resolution limit. Therefore, since it is possible to record data in the optical recording disc 10 at a high density,

it is possible to markedly increase the storage capacity of the optical recording disc
10.

Further, according to this preferred embodiment, since the decomposition reaction layer is formed so that x in the chemical formula: PtO_x of

- 5 the platinum oxide is equal to or larger than 1.0 and the decomposition reaction layer has a light absorption coefficient k equal to or lower than 2.0, even in the case where the length of a recording mark or the length of a blank region between neighboring recording marks constituting a recording mark train is shorter than the resolution limit, it is possible to obtain a reproduced signal having a good signal
10 characteristic.

WORKING EXAMPLES

Hereinafter, a working example and a comparative example will be set out in order to further clarify the advantages of the present invention.

- A light transmissible substrate having a thickness of 0.6 mm and a
15 diameter of 120 mm was set in a sputtering apparatus "CFS-4ES-231" (Product Name) manufactured by SHIBAURA MECHATORONICS CORPORATION and a first dielectric layer having a thickness of 130 nm was formed on the light transmissible substrate by a sputtering process using a target of a mixture of ZnS and SiO₂. The mole ratio of ZnS to SiO₂ in the mixture of ZnS and SiO₂ used as
20 the target was 85:15.

Then, a decomposition reaction layer containing platinum as a primary component and having a thickness of 4 nm was formed on the surface of the second dielectric layer by a sputtering process using a mixed gas of an Ar gas and an oxygen gas as a sputtering gas and a Pt target. When the decomposition
25 reaction layer was to be formed, the flow ratio of the oxygen gas in the mixed gas was set to 20 %, the film forming power of the sputtering apparatus was set to 50 W, the power density, i.e., the power applied to the target per unit area of the

target, was set to 1.09 W/cm² and the gas pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, was set to 0.5 Pa.

The film forming rate when the decomposition reaction layer was formed was measured and found to be 79.0 Å/min. Further, after forming the 5 decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured using a Rutherford backscatter analysis system “3S-R10” (Product Name) manufactured by National Electrostatics Corporation. It was found that x in the chemical formula: PtO_x of the platinum oxide was 1.7.

10 Further, a second dielectric layer having a thickness of 40 nm was then formed on the surface of the decomposition reaction layer by a sputtering process using a target of a mixture of ZnS and SiO₂. The mole ratio of ZnS to SiO₂ in the mixture of ZnS and SiO₂ used as the target was 85:15.

15 Then, a light absorption layer having a thickness of 60 nm was formed on the surface of the second dielectric layer by a sputtering process using a target of alloy having a composition Ag_{6.0}In_{5.5}Sb_{60.8}Te_{28.7}. The composition of the light absorption layer was Ag_{6.0}In_{5.5}Sb_{60.8}Te_{28.7} in terms of atomic ratios similarly to that of the target.

20 Furthermore, a third dielectric layer having a thickness of 100 nm was then formed on the surface of the light absorption layer by a sputtering process using a target of a mixture of ZnS and SiO₂. The mole ratio of ZnS to SiO₂ in the mixture of ZnS and SiO₂ used as the target was 85:15.

Thus, an optical recording disc sample # 1 was fabricated.

25 Then, an optical recording disc sample # 2 was fabricated in the manner of fabricating the optical recording disc sample # 1 except that the decomposition reaction layer was formed by setting the film forming power of the sputtering apparatus to 100 W, setting the power density to 2.19 W/cm² and setting the gas pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, to 2.0 Pa.

Similarly to the optical recording disc sample # 1, the film forming rate when the decomposition reaction layer was formed was measured and found to be 112.4 Å/min. Further, after forming the decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured

- 5 similarly to the optical recording disc sample # 1. It was found that x in the chemical formula: PtO x of the platinum oxide was 1.7.

Then, an optical recording disc sample # 3 was fabricated in the manner of fabricating the optical recording disc sample # 1 except that the decomposition reaction layer was formed by setting the film forming power of the
10 sputtering apparatus to 100 W, setting the power density to 2.19 W/cm² and setting the gas pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, to 0.5 Pa.

Similarly to the optical recording disc sample # 1, the film forming rate when the decomposition reaction layer was formed was measured and found
15 to be 208.2 Å/min. Further, after forming the decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured similarly to the optical recording disc sample # 1. It was found that x in the chemical formula: PtO x of the platinum oxide was 1.3.

Then, an optical recording disc sample # 4 was fabricated in the manner of fabricating the optical recording disc sample # 1 except that the decomposition reaction layer was formed by setting the film forming power of the
20 sputtering apparatus to 200 W, setting the power density to 4.39 W/cm² and setting the gas pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, to 0.5 Pa.

25 Similarly to the optical recording disc sample # 1, the film forming rate when the decomposition reaction layer was formed was measured and found to be 293.2 Å/min. Further, after forming the decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured

similarly to the optical recording disc sample # 1. It was found that x in the chemical formula: PtO x of the platinum oxide was 0.6.

Then, an optical recording disc sample # 5 was fabricated in the manner of fabricating the optical recording disc sample # 1 except that the

- 5 decomposition reaction layer was formed by setting the film forming power of the sputtering apparatus to 100 W, setting the power density to 2.19 W/cm 2 and setting the gas pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, to 0.1 Pa.

- Similarly to the optical recording disc sample # 1, the film forming
10 rate when the decomposition reaction layer was formed was measured and found to be 174.4 Å/min. Further, after forming the decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured similarly to the optical recording disc sample # 1. It was found that x in the chemical formula: PtO x of the platinum oxide was 1.0.

- 15 Then, an optical recording disc sample # 6 was fabricated in the manner of fabricating the optical recording disc sample # 1 except that the decomposition reaction layer was formed by setting the flow ratio of oxygen contained in the mixed gas to 80 %, setting the film forming power of the sputtering apparatus to 100 W, setting the power density to 2.19 W/cm 2 and setting the gas
20 pressure, *i.e.*, the pressure within the chamber during introduction of the Ar gas and the oxygen gas, to 0.5 Pa.

- Similarly to the optical recording disc sample # 1, the film forming rate when the decomposition reaction layer was formed was measured and found to be 48.6 Å/min. Further, after forming the decomposition reaction layer, the
25 content of oxygen contained in the decomposition reaction layer was measured similarly to the optical recording disc sample # 1. It was found that x in the chemical formula: PtO x of the platinum oxide was 1.7.

Next, an optical recording disc sample # 7 was fabricated in the following manner.

A light transmissible substrate was first set in a sputtering apparatus "CFS-4ES-231" (Product Name) manufactured by SHIBAURA MECHATORONICS CORPORATION and a first dielectric layer was formed on the surface of the light transmissible substrate in the manner of fabricating the optical recording disc

5 sample # 1.

Then, a decomposition reaction layer containing platinum as a primary component and having a thickness of 4 nm was formed on the surface of the second dielectric layer by a sputtering process using a mixed gas of an Ar gas and an oxygen gas as a sputtering gas and a Pt target. When the decomposition 10 reaction layer was to be formed, the flow ratio of the oxygen gas in the mixed gas was set to 33 %, the film forming power of the sputtering apparatus was set to 50 W, the power density was set to 0.79 W/cm² and the gas pressure, i.e., the pressure within the chamber during introduction of the Ar gas and the oxygen gas, was set to 0.14 Pa.

15 The film forming rate when the decomposition reaction layer was formed was measured and found to be 60.1 Å/min. Further, after forming the decomposition reaction layer, the content of oxygen contained in the decomposition reaction layer was measured similarly to the optical recording disc sample # 1. It was found that *x* in the chemical formula: PtO*x* of the platinum 20 oxide was 1.2.

Further, a second dielectric layer, a light absorption layer and a first dielectric layer were sequentially formed on the surface of the decomposition reaction layer in the manner of fabricating the optical recording disc sample # 1, thereby fabricating an optical recording disc sample # 7.

25 Then, the refractive index *n* and light absorption coefficient *k* of the decomposition reaction layer of each of the optical recording disc samples # 1 to # 7 were measured using an automatic ellipsometer "DHA-OLX/S4M" (Product Name) manufactured by Mizojiri Optical Co., Ltd.

The results of the measurement are shown in Table 1.

Table 1

	x	n	k
SAMPLE# 1	1.7	2.77	0.75
SAMPLE# 2	1.7	2.35	0.39
SAMPLE# 3	1.3	3.03	1.32
SAMPLE# 4	0.6	2.91	2.90
SAMPLE# 5	1.0	3.20	1.98
SAMPLE# 6	1.7	2.40	0.8
SAMPLE# 7	1.2	3.03	1.69

As shown in Table 1, it was found that the light absorption coefficient

- 5 *k* of the decomposition reaction layer was equal to or lower than 2.0 in each of the
optical recording disc samples # 1 to # 3 and # 5 to # 7 in which *x* of platinum
oxide PtOx contained in the decomposition reaction layer was equal to or larger
than 1.0 and that the decomposition reaction layer of each of the optical recording
disc samples # 1 to # 3 and # 5 to # 7 had the lower light absorption coefficient *k*
10 than that of the decomposition reaction layer of the optical recording disc sample #
4 in which *x* of platinum oxide PtOx contained in the decomposition reaction layer
was lower than 1.0 and had a high transparency with respect to a laser beam.

Then, the optical recording disc sample # 1 was set in an optical
recording medium evaluation apparatus "DDU1000" (Product Name) manufactured
15 by Pulstec Industrial Co., Ltd. and the optical recording disc sample # 1 was
irradiated with a red laser beam having a wavelength λ of 635 nm using an
objective lens having an NA (numerical aperture) of 0.60 from the side of the light
transmissible substrate, thereby forming recording marks in the decomposition
reaction layer of the optical recording disc sample # 1 under the following
20 conditions so that the lengths of the recording marks were 200 nm. The recording
power of the laser beam was set to 11.0 mW.

Recording linear velocity: 6.0 m/sec

Recording format: on-groove recording

Next, a recording mark was formed in each of the optical recording disc samples # 2 to # 7 using the above mentioned optical recording medium

- 5 evaluation apparatus in the manner of forming the recording mark in the optical recording disc sample # 1, thereby recording data in each of the optical recording disc samples # 2 to # 7. Here, the recording powers of the laser beams were set to 14.0 mW, 10.0 mW, 8.0 mW, 8.0 mW, 12.0 mW and 10.0 mW, respectively.

Then, data recorded in each of the optical recording disc samples # 1

- 10 to # 7 were reproduced using the above mentioned optical recording medium evaluation apparatus and the signal characteristics of the thus reproduced signal were evaluated using a spectrum analyzer. Here, the reproducing power of the laser beam was set to 4.0 mW and the linear reproducing velocity was set to 6.0 m/sec.

- 15 Among the frequency spectrums of the reproduced signals obtained from the optical recording disc samples # 1 to # 7, the frequency spectrums of the reproduced signals obtained from the optical recording disc samples # 1 to # 4 are shown in Figures 6, 7, 8 and 9, respectively. In Figures 6, 7, 8 and 9, the ordinate axis indicates the level of the reproduced signal and the abscissa axis indicates 20 the frequency of the reproduced signal.

Then, the waveform of the signal obtained by reproducing data recorded in each of the optical recording disc samples # 1 to # 7 was evaluated using an oscilloscope.

- Among the waveforms of the reproduced signals obtained from the 25 optical recording disc samples # 1 to # 7, the waveforms of the reproduced signals obtained from the optical recording disc samples # 1 to # 3 displayed on the screen of the oscilloscope are shown in Figures 10, 11 and 12, respectively. Here, in Figures 10, 11 and 12, the ordinate axis indicates the voltage value obtained by

photoelectrically converting the laser beam reflected from each of the optical recording disc samples # 1 to # 3 and the abscissa axis indicates time.

The waveform of a reproduced signal obtained from the optical recording disc sample # 4 was also displayed on the screen of the oscilloscope but

- 5 was found to be very distorted and the signal characteristics of the reproduced signal obtained from the optical recording disc sample # 4 could not be properly evaluated. Thus, it was judged that it was impossible to evaluate the signal characteristics of the reproduced signal obtained from the optical recording disc sample # 4.

10 As apparent from Figure 6 to 9, it was found that in the case where the recording mark having a length of 200 nm was formed in each of the optical recording disc samples # 1 to # 3 in which x of platinum oxide PtOx contained in the decomposition reaction layer was equal to or larger than 1.0 and the light absorption coefficient k of the decomposition reaction layer was equal to or lower 15 than 2.0, thereby recording data therein, the noise intensity of the reproduced signal in a frequency band equal to or lower than 10 MHz, which is lower than the spatial frequency of 15 MHz of the recording mark having a length of 200 nm, was smaller than that of the optical recording disc sample # 4 in which x of platinum oxide PtOx contained in the decomposition reaction layer was smaller than 1.0 and 20 the light absorption coefficient k of the decomposition reaction layer exceeded 2.0. It was therefore found that the noise signal contained in the reproduced signal could be suppressed in each of the optical recording disc samples # 1 to # 3.

Further, it was found that the noise signal contained in the reproduced signal could be suppressed in each of the optical recording disc 25 samples # 5 to # 7 in which x of platinum oxide PtOx contained in the decomposition reaction layer was equal to or larger than 1.0 and the light absorption coefficient k of the decomposition reaction layer was equal to or lower than 2.0, similarly to the optical recording disc samples # 1 to # 3.

Furthermore, as apparent from Figures 10 to 12, it was found that in each of the optical recording disc samples # 1 to # 2 in which x of platinum oxide PtOx contained in the decomposition reaction layer was equal to or larger than 1.0 and the light absorption coefficient k of the decomposition reaction layer was equal 5 to or lower than 2.0, the amplitude of the signal obtained by reproducing data recorded by forming a recording mark having a length of 200 nm therein was substantially constant and the variation in the amplitude of the reproduced signal was small, while in the optical recording disc sample # 3 in which x of platinum oxide PtOx contained in the decomposition reaction layer was equal to or larger 10 than 1.0 but smaller than that in the optical recording disc samples # 1 to # 2, the amplitude of the signal obtained by reproducing data recorded by forming a recording mark having a length of 200 nm therein varied slightly.

Moreover, it was found that in each of optical recording disc samples # 5 to # 7 in which x of platinum oxide PtOx contained in the decomposition 15 reaction layer were 1.0, 1.7 and 1.2, respectively, the amplitude of the signal obtained by reproducing data recorded by forming a recording mark having a length of 200 nm therein was substantially constant and the variation in the amplitude of the reproduced signal was small and that the variation in the amplitude of the reproduced signal became smaller as x of platinum oxide PtOx 20 contained in the decomposition reaction layer was larger.

The present invention has thus been shown and described with reference to specific embodiments and a working example. However, it should be noted that the present invention is in no way limited to the details of the described arrangements but changes and modifications may be made without departing from 25 the scope of the appended claims.

For example, although the optical recording disc 1 according to the preferred embodiment shown in Figures 1 and 2 is constituted by laminating the first dielectric layer 4, the decomposition reaction layer 5, the second dielectric layer 6, the light absorption layer 7 and the third dielectric layer 8 on the light

transmissible substrate 2, the present invention is not limited to an optical recording disc having such layer configuration and a reflective layer may be formed on the surface of the third dielectric layer 8 in order to improve the reflectance with respect to the laser beam L. Further, a protect coat layer may be

5 formed on the surface of the third dielectric layer 8 in order to protect it, and another substrate may be adhered to the surface of the third dielectric layer 8 in order to improve the rigidity of the optical recording disc 1.

Furthermore, in the optical recording disc 10 according to the preferred embodiment shown in Figure 4 and 5, similarly to in the optical recording disc 1, it is also possible to form a reflective layer between the third dielectric layer 8 and the support substrate 12 in order to improve the reflectance with respect to the laser beam L.

Moreover, in the optical recording disc 1 according to the preferred embodiment shown in Figures 1 and 2 and the optical recording disc 10 according to the preferred embodiment shown in Figures 4 and 5, although the decomposition reaction layer 5, the second dielectric layer 6 and the light absorption layer 7 are laminated in this order from the side of the light incidence plane of the laser beam L, the present invention is not limited to an optical recording disc having such layer configuration. For example, the decomposition reaction layer 5, the second dielectric layer 6 and the light absorption layer 7 may be laminated in this order from the side opposite to the light incidence plane of the laser beam L or a light absorption layer, a dielectric layer, a decomposition reaction layer, a dielectric layer and a light absorption layer may be laminated in this order from the side of the light incidence plane of the laser beam L. In other words, in the present invention, it is sufficient for an optical recording disc to include a laminated body formed by laminating a decomposition reaction layer and a light absorbing layer so as to sandwich at least a dielectric layer.